



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2814
Examiner: Dana FARAHANI

In Re PATENT APPLICATION Of:

Applicant(s): Yoshinori SHIZUNO

Serial No.: 09/705,729

Filed: November 6, 2000

For: SEMICONDUCTOR DEVICE AND METHOD
OF MANUFACTURING THE SAME

Docket No.: OKI-267

)
)
)
)
) **REQUEST FOR**
) **RECONSIDERATION**
)
)
)

February 2, 2004

MAIL STOP: AF

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Reconsideration of the final rejections presented in the Examiner's Action mailed
on December 19, 2003, is requested for at least the following reasons:

FREE ENCLOSED: \$
Please charge any further
fees to our Deposit Acc unt
No. 18-0002